



500.39750VX1

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: OHMOTO et al  
Serial No.: 10/663,646  
Filed: September 17, 2003  
For: Plasma Processing Apparatus  
Art Unit: 1763  
Examiner: R. Dhingra

**AMENDMENT**

Mail Stop: Amendment (Fee)  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

November 21, 2006

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application, in response to the Office Action dated June 22, 2006. The amendments are listed below and set forth on the following pages.

Amendments to the Claims; and

Remarks are included following the amendments.